## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: K.R. Udayakumar, et al.

Serial No.: 10/721,932

Filed: November 25, 2003

Title: A METHOD FOR ETCHING A SUBSTRATE AND A DEVICE

FORMED USING THE METHOD

Grp./A.U.: 1765

Examiner: Lan Vinh

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Thereby certify that this correspondence is being electronically filed with United States Patent and trademark Office on:

May 5, 2006 (Date)

Elizabeth Schumacher

(Printed or typed name of person signing the certificate)

Ehzabeth Schumacher

(Signature of the person signing the certificate)

Sir:

## **REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.116**

In response to the Examiner's Action mailed March 6, 2006, please reconsider the aboveidentified application for the following reasons: